




DOCKET NO: VSEA 26-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Steven R. Walther
Serial No: 10/006,462
Confirmation No: 5689
Filed: December 4, 2001
For: DOSE UNIFORMITY CONTROL FOR PLASMA DOPING
SYSTEMS
Examiner: Michelle Crowell
Art Unit: 1763

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 21st day of March, 2005.



Janine Canillas

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:


Petition for Extension of Time

A three-month extension of time to November 6, 2003 is requested for response to the Examiner's Office Action of May 6, 2004.

The extension fee of \$1020.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

04/01/2005 MHEKONEN 00000015 500896 10006462
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Respectfully submitted,
Steven R. Walther, Applicant

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